

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811

Examiner: Crane, Sara W.

Serial No.: 10/723,285

Filed: November 25, 2003

In re Application of: Werner et al.

For: SEMICONDUCTOR STRUCTURE FOR USE IN THE NEAR INFRARED REGION
AND A METHOD OF MANUFACTURING THIS SEMICONDUCTOR
STRUCTURE

37 C.F.R. §1.312 AMENDMENT AFTER ALLOWANCE

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir or Madam:

In response to the Notice of Allowance dated April 6, 2006, kindly amend the above-identified application as follows.